

	Type	Hits	Search Text	DBs	Time Stamp
28	BRS	15410	etching with polishing	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:05
29	BRS	340	etching with polishing and conductive adj plug	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:05
30	BRS	322	etching with polishing and conductive adj plug and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:09
31	BRS	90	etching with polishing and conductive adj plug and semiconductor and contact adj plug	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:09
32	BRS	27	((polish\$3 or CMP) with remov\$3 near3 portion with tungsten) and (tungsten adj plug)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:14
33	BRS	32	((polish\$3 or CMP) with remov\$3 near3 portion with metal) and (contact adj plug)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/01/24 13:16